

Electronic Acknowledgement Receipt

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Application Number:	10711310
International Application Number:	
Confirmation Number:	5309
Title of Invention:	Method of Managing Wafer Defects
First Named Inventor/Applicant Name:	Hung-En Tai
Customer Number:	27765
Filer:	Winston Hsu
Filer Authorized By:	
Attorney Docket Number:	LKSP0051USA
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	LKSP0051USA_A2_1_amend.pdf	647460 8d67b4d5698028f1374c064e92e2eb2982ad303821	no	1
Warnings:					
Information:					
2	Specification	LKSP0051USA_A2_1_spec.pdf	647443 ba829k430a6c09b897bc0352197c0954554e481	no	2
Warnings:					
Information:					
3	Claims	LKSP0051USA_A2_1_claim.pdf	647424 3dee159d7456ba3f40150a002b2b4baad4d3	no	3
Warnings:					
Information:					
4	Applicant Arguments/Remarks Made in an Amendment	LKSP0051USA_A2_1_remarks.pdf	647443 44773e46650f426483aee35a25a904e78995473	no	2
Warnings:					
Information:					
5	Extension of Time	LKSP0051USA_A2_1_extension.pdf	647468 b1745392v08a291a8f96c2850b9d1d3c3d257c1e6	no	1
Warnings:					
Information:					
6	Fee Worksheet (PTO-06)	fee-info.pdf	8123 bcb13ba2c378f25d3af49c3e13413e0998927a641	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			3245361		

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National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

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